

OUTLOOK FOR ADVANCED CLEANS

Business of Cleans April 9, 2018

Mike Corbett Linx Consulting Inc.

Outline



- Introduction to Linx Consulting
- Semi Industry Outlook
- Materials Challenges
- Impact on Suppliers
- Conclusions



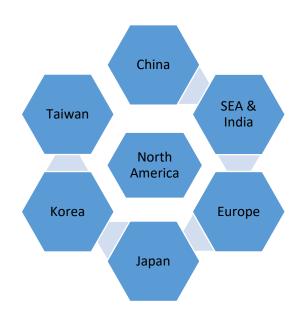
Introduction to Linx Consulting





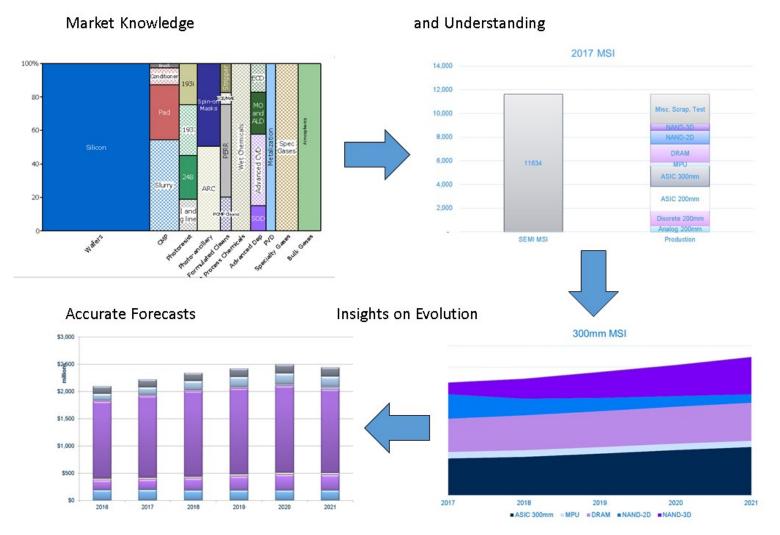


- 1. We help our clients to succeed by creating knowledge and developing unique insights at the intersection of electronic thin film processes and the chemicals industry on a global basis
- 2. The knowledge is based on a core understanding of the semiconductor device technology; manufacturing processes and roadmaps; and the global structural industry dynamics
- 3. This knowledge is leveraged to create advanced models, simulations and real-world forecasts
- 4. Our perspectives are by direct research and leveraging our extensive experience throughout the global industry value chain



MSI Breakdown & Forecasts





Linx Consulting Service Portfolio



Full Service

- Forecast Service
- Technology Trends

Multi-Client Reports

- IC Materials
 - CMP
 - · Deposition
 - Patterning
 - Cleaning
 - Gases
 - Bulk Chemicals
 - Packaging

• Econometric Semiconductor Forecast

- Financial planning
- Sales and Operational planning
- Forecasting

With Hilltop Economics LLC

- Conference Production
 - The Business of Cleans & SPCC

Proprietary Projects

- Market Planning
- M&A
- · Growth and Diversification
- · Supply Chain Optimization
- Technology Commercialization
- · Strategic Planning
- Voice of the Customer
- Market Diligence

Cost Modeling

- Client demand modeling
- Product development
- Bill of Materials quantification

With IC Knowledge, LLC

- · Wafer Start Demand Forecasting
 - Device type and technology node



Semi Industry Outlook

Industry Trends Summary

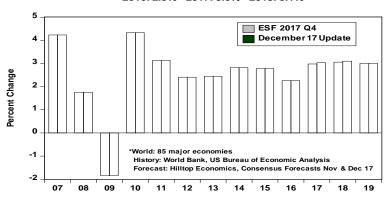


- Healthy GDP growth rates expected in all major regions
- Record levels of CapEx reflect very high utilization (>95%) across both 200 mm and 300 mm fabs, driven by record demand for Logic and 3D NAND chips
- Fifteen IDMs exceed \$1B spend in 2017, spanning US-based (Intel, Micron, Global Foundries), European (ST Micro, Infineon) and Asian companies
- Samsung remains the industry top spender, with \$20B CapEx forecasted for both 2017 and 2018
- Geographically, new fab construction is highly concentrated in Asia, with China investment dominating the list
- Several trends support such rapid industry expansion
 - Some are already driving significant volume of chips, e.g. next-generation communication networks, automotive electronics/ADAS, and Internet of Things/IoT
 - Others are nascent and will fuel this growth for years to come, e.g. Artificial Intelligence/AI, VR/AR technologies, and autonomous vehicles

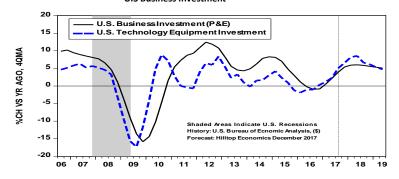
Economic Drivers



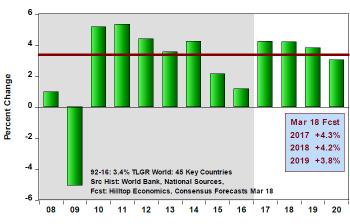
World* Real GDP Growth 2016: 2.3% 2017: 3.0% 2018: 3.1%



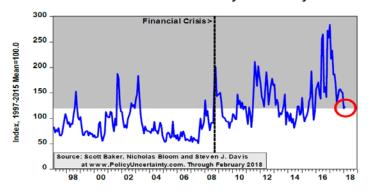
U.S Business Investment



World* Real Investment



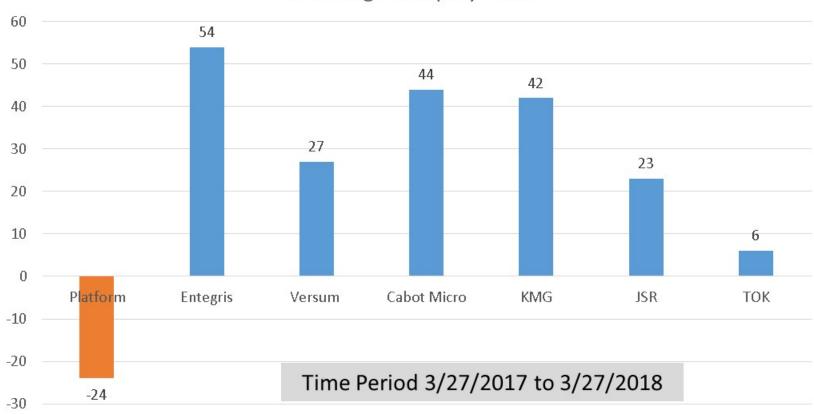
Global Economic Policy Uncertainty



Linx WFM Equity Index



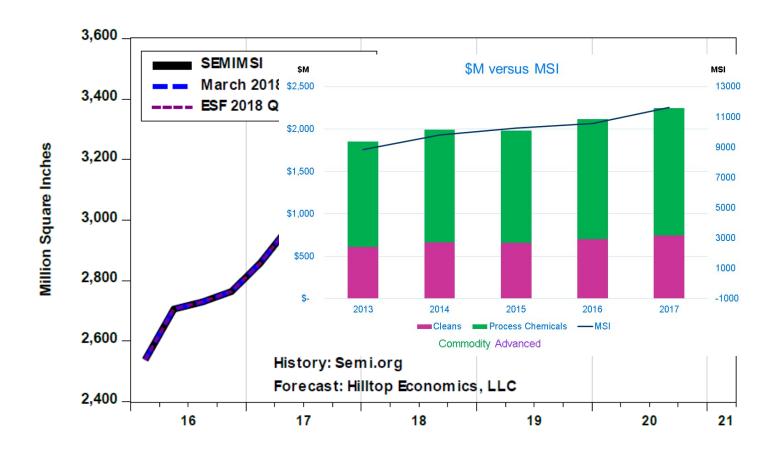




Latest MSI Forecast by ESF Model

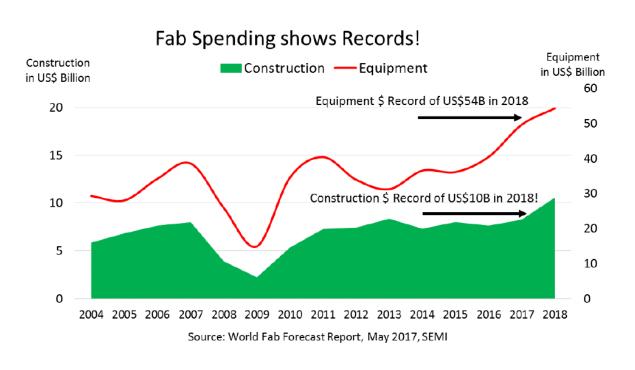


Semiconductor Forecast: ESF 2018 Q1



Record Levels of Capex





Fab equipment spending includes new and secondary equipment; and facilities for such

Billion Dollar Spenders in 2017

- Samsung
- Intel
- TSMC
- SK Hynix
- Micron
- Toshiba
- GLOBALFOUNDRIES
- SMIC
- Western Digital (SanDisk)
- UMC
- Nanya
- Sony
- Infineon
- ST Microelectronics
- Renesas

Capacity Utilization for 200mm and 300mm fabs > 95% in 2017





Driven by NAND, DRAM and Foundry

NAND

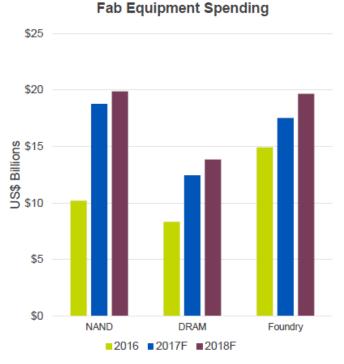
- Samsung Pyeongtaek P1
- SK Hynix M14 3D NAND line
- Micron Building 60 (Lehi) and Fab 10X in Singapore
- Toshiba/Flash Alliance Fab 2, Fab 6 and new R&D Center
- Intel Fab 68 in China

DRAM

- Samsung Pyeongtaek P1 and Line 15
- · Micron Fab 15 (Hiroshima) and Fab 16
- SK Hynix M14

Foundry

- TSMC Fab 12, Fab 14 and Fab 15
- Samsung S2 and S3
- GLOBALFOUNDRIES Fab 1, Fab 8 and Fab 11
- SMIC Beijing B2 and B3, new Shanghai 300mm fab and Shenzhen 300mm fab
- · UMC Fab 12A P5 and Xiamen fab



Source: SEMI World Fab Forecast, December 2017

3DN and Logic driving growth. Vertical scaling helps drive Materials Growth



Materials Challenges

Trends Impacting WFM Suppliers



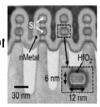


Materials Opportunities

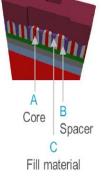


Demand Drivers

- CuBS demand increasing in Logic Interconnect
 - Limitations of current architectures
- FinFET gate deposition
 - GAA Nanowire develop:
 - High mobility materials



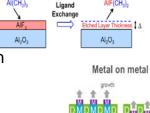
- Memory technology extension
 - 3D-NAND growth
 - DRAM capacitor dielectric
 - Novel architectures
- Pitch doubling and quadrupling
 - Low temperature spacers



Lithography aids

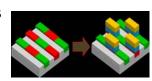
Opportunities

- Possible changes in conductor metal
 - Cu ⇒ Co Barrier ⇒ Co plating
- 3D-NAND aspect ratio
 - Hard mask technology
 - 2D stair-step
- Novel process development
 - Multi color, self aligning etch
 - CVD ⇔ Continuous etch
 - ALD ⇔ ALE
- Self Assembling Materials for selective processes
- Few new PVD applications
 - 3DXpoint / MRAM?
- Selective Deposition
 - Self Assembling Materials
 - Selective Deposition



Fluorination

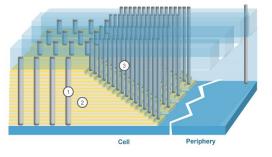




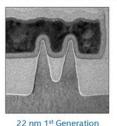
The Cleaning Market Environment

- Technology The cleaning challenge continues to increase, and new, smaller device structures and materials will increase the difficulty of preparing the wafer for the next process step. Enabling technologies are valued significantly more by end-users than "like" or "me too" products.
- Proliferation of novel materials in gate architecture, memory cell technology, interconnect and packaging is adding complexity in material choice and formulation.
- Increased Customization Customers are increasingly specifying custom products for layer specific problems.

New Materials and Architectures Enable Moore's Law



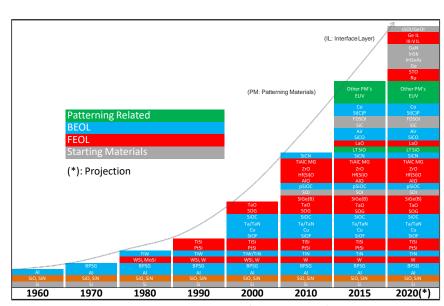
Transistor Fin Improvement



Tri-gate Transistor



① Channel ② Gate Stack ③ 3D Shaping

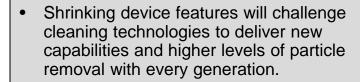


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Defectivity Paradigm Shift & Cleans



- Pursuit of Moore's Law is driving ever increasing design innovation, process sensitivity & complexity
- Paradigm shift in thoughts about what we did not care about earlier in >20nm era & what we care to control now!
 - Complex Chemistry: Compatibility Issues
 - New Defect Sources, increase Defect Sensitivity
- Metrology techniques of all types are challenged to provide sufficient sensitivity for early detection & prevention
 - Supplier Infrastructure
 Development needed for better defect detection & characterization
 - Metrology and Quality Control
- Proactive engagement and collaboration across the supply chain are essential to HVM readiness



- These shrinking geometries will challenge clean technologies to move beyond purely undercutting particulates to removal without loss of the underlying substrate.
- Three-dimensional structures (3D Gate structures and stacked storage devices) will constrain chemical and physical approaches to cleaning, and require novel technologies to achieve defect free results.
- Such three-dimensional structures will have extreme aspect ratios, and very challenging mass transport requirements for the removal of contaminants from deep structures.



Source: Archita Sengupta, Intel

Trends - WFM Spend at Advanced Nodes





Trends in Advanced Technology Wet Cleans

Wet chemical consumption per wafer is increasing

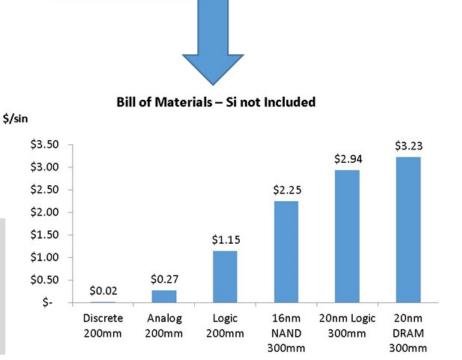
- · Proliferation of single-wafer processing, higher number of layers
- · Multi-step patterning, more complex process flows
- · Defect reduction, less recycle

Larger volumes increase scrutiny on chemical cost (\$)



Trend driven by:

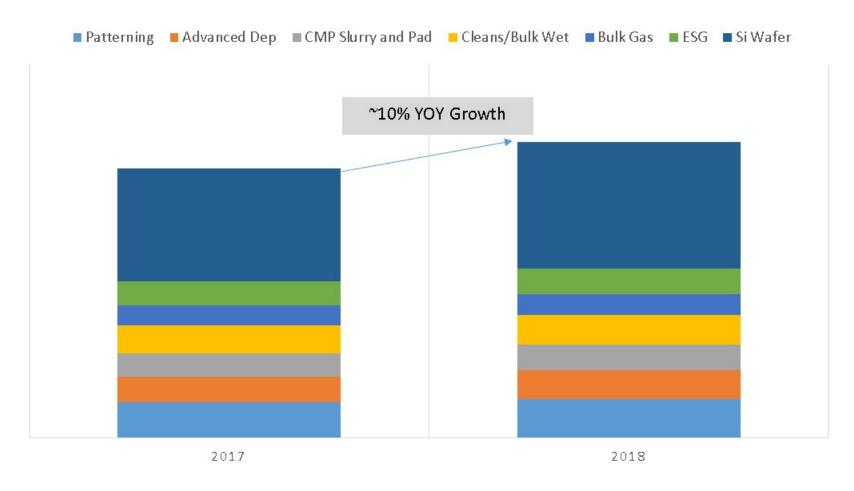
- Increased # of interconnect and FEOL layers
- RMG process
- Multi-Patterning
- · New materials integration



Source: Linx, IC Knowledge, Intel

WFM Materials Outlook





Advanced Cleans Outlook



3% CAGR



Paths Forward for Consumables



ADVANCED / SPECIALTY

- Enable novel architectures and litho schemes:
 - 3DN
 - FinFET
 - Horizontal Nano wire
- Enable new memory technologies
 - PCM
 - STT MRAM
- Enable new BEOL materials
 - Cobalt, Ru
 - Alternative/self forming barrier
- Solve productivity and defectivity problems

COMMODITY

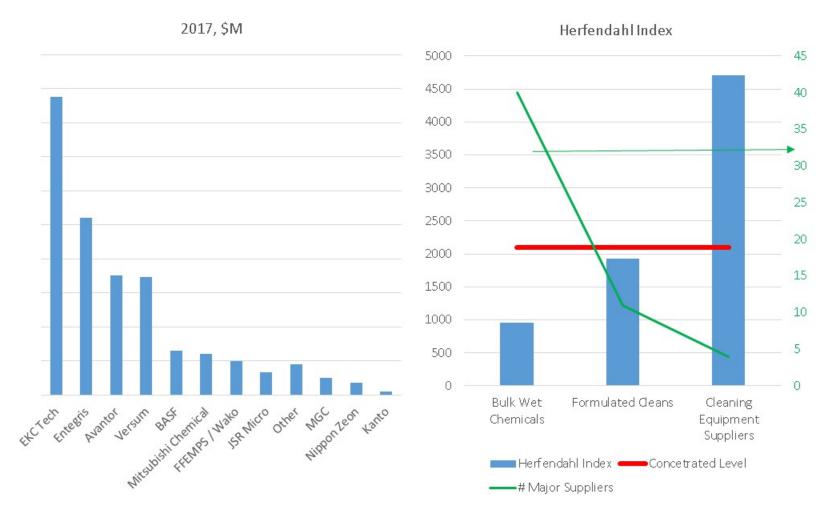
- Have evolved from current materials base
- Need to be drop-in ready
- Are readily copied
- Will compete based on cost
- Most impacted by changes to business model



Impact on Suppliers

Leading Suppliers Formulated Cleans





Regional & Structural Trends



Recent Transactions

- Cabot Microelectronics NexPlanar
 - Fujimi Collaboration
- FujiFilm EM Ultra Pure + Wako
- Wonik Nova-Kem
- NATA Kempur
- Air Liquide AirGas + Voltaix
- Air Products Versum Materials spinout
- SK OCIM + Tri-Chem

- Dow Chemical DuPont + Dow Corning
- Global Wafer -SunEdison
- Yoke UPChem
- Versum Dynaloy
- SK Holding LG Siltron + OCIM
- Linde + Praxair
- Avantor Gelest

China

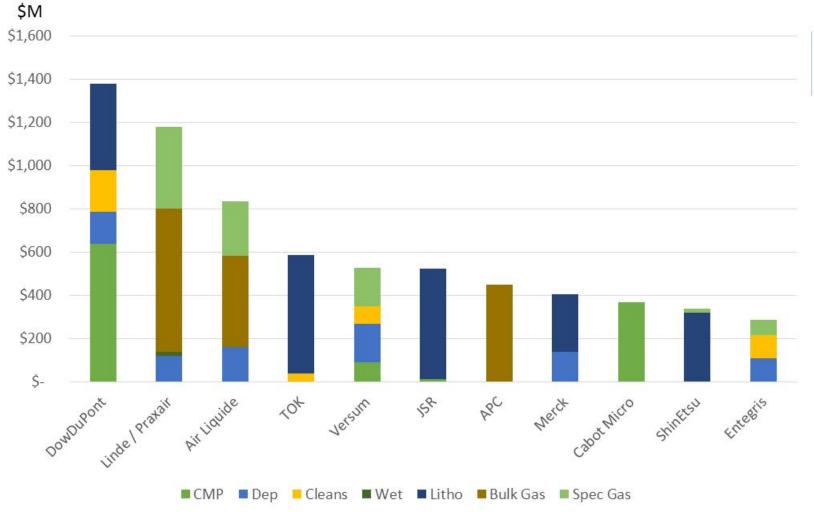
- Leveraged government equity positions to enable significant sized acquisitions
- Continued acquisition activity from multiple companies.
- Acquisitions along the line of key product areas:
 - Silicon
 - Gases
 - Lithography materials
 - Advanced deposition materials

Korea

- Korean companies also looking to change business model
- Gain international market access

Top Tier WFM Suppliers







Conclusions

Conclusions



- Sustainable strong growth outlook anticipated for several years
- 3D structures and new materials will continue to drive semiconductor technology advancement at 1Xnm and beyond.
- 200mm and older wafer fab is expected to remain at high levels of capacity utilization over the next several years. Productivity will be a major driver
- Concentrated customer base and tool supplier base, along with increasing barriers to serve end-users will drive WFM consolidation
- New capacity in China will enable new suppliers who will initially compete with special commodities
- Expect Korea to focus more effort on specialty chemicals